

PCT/IB2004/002444

Relevant to daim No.

A. CLASSIFICATION OF SUBJECT MATTER IPC 7 G03F7/20

C. DOCUMENTS CONSIDERED TO BE RELEVANT

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Category °

Minimum documentation searched (classification system followed by classification symbols) IPC 7-603F-H01L

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, COMPENDEX, INSPEC, WPI Data, IBM-TDB

Citation of document, with indication, where appropriate, of the relevant passages

х	US 2003/068565 A1 (KI WON-TAI	ET AL)	10,11	
A	10 April 2003 (2003-04-10) abstract		1 10	
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X Furti	ner documents are listed in the continuation of box C.	χ Patent family members are listed i	n annex.	
° Special ca	tegories of cited documents:	ATT 1.4		
"A" document defining the general state of the art which is not		or priority date and not in conflict with	"T" later document published after the international filing date or priority date and not in conflict with the application but	
considered to be of particular relevance		cited to understand the principle or theory underlying the invention		
"E" earlier document but published on or after the international filling date		"X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to		
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citation or other special reason (as specified)		"Y" document of particular relevance; the cannot be considered to involve an in-	laimed invention ventive step when the	
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P document published prior to the international filing date but		in the art.		
later than the priority date claimed		*&" document member of the same patent		
Date of the actual completion of the international search		Date of mailing of the international sea	Date of mailing of the international search report	
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NL - 2280 HV Rijswijk Tel. (+31-70) 340-2040, Tx. 31 651 epo nl,				
	Fax: (+31-70) 340-2040, 1x. 31 651 epo ni,	Menck, A		
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C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT	
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